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Plagiarism Report and GitHub Link

Topic- Attendance Management system using Facial recognition.

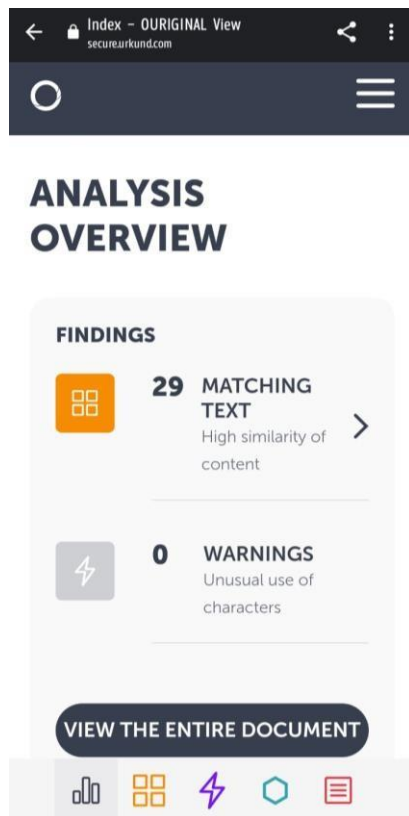
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Click here to open the analysis:

<https://secure.urkund.com/view/147202407-606651-146743>

Screenshots-



GitHub link: <https://github.com/nikita151/Attendance-Managment-System-Using-Face-Recognition>